

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Tomoo IWIMA et al.

Serial Number: 09/466,895

Filed: December 20, 1999

Group Art Unit: 3729

For: WIRING SUBSTRATE FOR MOUNTING
SEMICONDUCTOR ELEMENTS AND
FABRICATING METHOD THEREOF

Examiner: S. SMITH

PETITION FOR EXTENSION OF TIMECommissioner for Patents
Washington, D.C. 20231

Date: January 14, 2002

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated September 14, 2001 for one month from January 14, 2001 to January 14, 2002.

Attached please find a check in the amount of \$110.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340. Two copies of this paper are enclosed herewith.

Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP

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